

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	Examiner: Unassigned		
TAKAHARU KONDO, ET AL.)	Group Art Unit: Unassigned		
Application No.: 10/693,914		; ;	Group Art Omt. Gnassigned		
Filed: October 28, 2003)			
For:	ZINC OXIDE FILM, PHOTOVOLTAIC DEVICE MAKING USE OF THE SAME, AND ZINC OXIDE FILM FORMATION PROCESS	; ;) ;	May 14, 2004		

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed articles are enclosed.

The listed articles are discussed at page 2 of the specification.

FORMAL MATTERS

In accordance with 37 C.F.R. § 1.97(b), since a first Office Action on the

merits of the subject application has not yet been issued, neither a statement under 37

C.F.R. § 1.97(e) nor payment of a fee is believed to be required for consideration of this

Information Disclosure Statement. However, the Commissioner is hereby authorized to

charge any fee which may be required in connection with this paper to Deposit Account

No. 06-1205. A duplicate of this paper is enclosed for that purpose.

CONCLUSION

It is respectfully requested that the above information be considered by the

Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such

information has been considered.

Applicants' undersigned attorney may be reached in our Washington D.C.

office by telephone at (202) 530-1010. All correspondence should continue to be directed

to our address given below.

Respectfully submitted,

Attorney for Applicants

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FORM PTO 1449	•	·CE	ATTY DOCKET NO. 03500.017666	APPLICAT	APPLICATION NO. 10/693,914			
F	J.S. DEPARTMENT OF COMMER PATENT AND TRADEMARK OFFI F REFERENCES CITED BY APPL	CE .ICANT(S)	APPLICANT TAKAHARU KONDO, ET AL.					
(Use several sheets if necessary) Date submitted to PTO: May 14, 2004			FILING DATE October 28, 2003		GROUP Unassigned			
			U.S. PATENT DOCUMENTS					
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE		
OTPE	2003-0085129 A1	05/08/2003	Shishido	205	155			
MAY 1 4 2004								
		FC	DREIGN PATENT DOCUMENTS		1			
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT		
		OTHER DOCUMENT(S	S) (Including Author, Title, Date, Pertinent Pages, E	Etc.)				
	Inoue et al., "Optica Extended Abstracts	al confinement s, Japan Socie	t effect in a-SiGe solar cells on ty of Appl. Phys., 1990, p. 747.	stainless ste	el substrat	tes",		
	Sannomiya et al., "a Tech. Dig. Int. PVSI	a-SiC/a-Si/a-Si EC-5, Kyoto, J	Ge Multi-Bandgap Stacked Sola apan, 1990, pp. 387-390.	ar Cells with	Bandgap I	Profiling",		
EYAMINED			DATE CONSIDERED					

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.